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Electronic Patent Application Submission
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EFS ID: 52471

Application ID: 10675419



Title of Invention:

Sacrificial Surfactanated Pre-Wet
for Defect Reduction in a Semi-
Conductor Photolithography
Developing Process

First Named Inventor: John Kulp

Domestic/Foreign Application: Domestic Application

Filing Date: 2003-09-30

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Statement

Filing Type:

Confirmation number: 6182

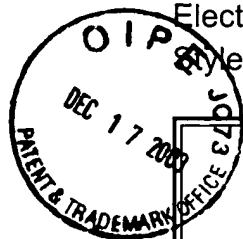
Attorney Docket Number: CT-001

Total Fees Authorized:

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TRANSMITTAL

Electronic Version v1.1
Stylesheet Version v1.1.0



Title of
Invention

Sacrificial Surfactanated Pre-Wet for Defect Reduction in a Semi-Conductor Photolithography Developing Process

Application Number: 10/675419



Date: 2003-09-30

First Named Applicant: John M. Kulp

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Submitted by:	Elec. Sign.	Sign. Capacity
Kristi L. Davidson Registered Number: 44643	Kristi L. Davidson	Attorney

Documents being submitted
us-ids

Files
CT-001-usidst.xml
us-ids.dtd
us-ids.xsl

Comments

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

Stylesheet Version v18.0

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Invention

Sacrificial Surfactanated Pre-Wet for Defect Reduction in a
Semi-Conductor Photolithography Developing Process

Application Number: 10/675419



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Search string: (6117486 or 6132940 or 6147010 or 6159662
or 6402398 or 6420101).pn.

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	6117486	2000-09-12	Yoshihara		427	240
	2	6132940	2000-10-17	Mih et al.		430	394
	3	6147010	2000-11-14	Whitman		438	782
	4	6159662	2000-12-12	Chen et al.		430	313
	5	6402398	2002-06-11	Szajewski et al.	B1	396	604
	6	6420101	2002-07-16	Lu et al.	B1	430	326

Remarks

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